Form PTO 1449 (Modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY DOCKET NO.		SERIAL NO.		
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LIST OF	REFE	RENCES CITED BY AP	PLICABOT	Jamal RAMDANI, et al.			
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WAY	ccs	WO 99/67882	12/29/99	WIPO			
1	ССТ	WO 95/02904	01/26/95	WIPO			
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	ccw	198 29 609	01/05/00	GERMANY			
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				Additional References sheet(s) attached			
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*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							